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Testing of submicrometer fluorescence microprobe based on Bragg–Fresnel crystal optics at the ESRF

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An x-ray fluorescence microprobe with circular Bragg–Fresnel lens was tested at the European Synchrotron Radiation Facility Microfocus beamline. A focal spot of $0.7\text{ }\mu\text{m}$ was observed using the knife-edge technique at the energy 7.6 keV (wavelength $1.6\text{ }\text{\AA}$). The intensity in the focal spot was measured to 10^8 ph/s in energy bandwidth of 10^{-5} . The fluorescence microprobe was applied for mapping $100\text{ }\mu\text{m}$ size micrometeorite at 13.5 keV . © 1995 American Institute of Physics.

I. INTRODUCTION

Recent experiments of x-ray focusing by single crystal Bragg–Fresnel lenses (BFL)^{1–5} have shown the real perspective of developing microprobe techniques on the basis of Bragg–Fresnel optics for microdiffraction⁴ and microfluorescence.⁵ The high brilliance and the coherence of an x-ray beams provided by a third generation of synchrotron radiation sources like ESRF make it possible to reach a submicrometer resolution: 10^8 ph/s was measured in $0.8\times 40\text{ }\mu\text{m}^2$ focal line with linear BFL.⁵ Linear microprobe has a number of attractive features including energy tunability in the range from 2 to 60 keV .⁶ Nevertheless, a number of diagnostic problems requires a 2D collimation of the x-ray beam. This can be achieved by applying two linear BFLs in cross setup^{1,2} or by using circular BFL in backscattering geometry.^{3,4} In this paper a 2D microprobe based on circular BFL was tested in order to examine the resolution and to study applicability for microfluorescence. Compared with the cross geometry of two linear BFLs, a circular BFL has an evident advantage of using simpler mechanics for BFL stage, since a single optical element (circular BFL) do not need any accurate angular positioning, which is the case for the cross geometry setup. Due to focusing in two directions one can expect better signal to noise ratio for the circular BFL compared to the linear one.

II. EXPERIMENT AND RESULTS

The performance of the fluorescence microprobe base on Bragg–Fresnel lens was tested at the ESRF Microfocus beamline (Fig. 1). A low- β undulator with the source size $130\times 90\text{ }\mu\text{m}^2$ was located at a distance of 35 m from the BFL. The 7.6 and 13.5 keV monochromatic beam was selected by an N_2 -cooled channel-cut Si monochromator and

was focused on a sample by a circular Ge BFL using 444 and 777 reflections in nearly backscattering geometry.

A circular phase BFL was fabricated on a Ge-111 substrate. The basic geometrical parameters of the BFL are: an outermost zone width of $0.15\text{ }\mu\text{m}$, the height of the structure of $2\text{ }\mu\text{m}$, and an aperture of $100\text{ }\mu\text{m}$ for 7.6 keV and $150\text{ }\mu\text{m}$ for 13.5 keV (Fig. 2). The BFL was mounted on an XYZ translation stage with a precise goniometer module, with horizontal axis of rotation, to allow an adjustment of the Bragg angle. A $70\text{ }\mu\text{m}$ pinhole was placed downstream of the lens just before the specimen to avoid the background radiation from the flat area of the Ge substrate.

A small He/Ne (red) laser was adjusted to simulate the

FIG. 1. Schematic display of the experimental setup. Focal distance, $F=10\text{ cm}$ for energy, $E=7.6\text{ keV}$ ($\lambda=1.6\text{ }\text{\AA}$) (a) and top view (b).

FIG. 2. SEM photograph of the circular BFL.

direction of the x-rays beam to perform an easy preliminary alignment of the lens. A "x-ray eye camera," Si PIN photodiode and Kodak high-resolution films were used for final adjustment of the setup. In Fig. 3 one can see the x-ray image of the focused beam taken with a high-resolution Kodak film placed a few millimeters behind the sample position (focal plane). The central high intensity focal spot is surrounded by the geometric shadow of the BFL aperture region, where the intensity is reduced substantially because only a small fraction of the incident beam is delivered to the zero diffraction order of the phase BFL. The intensity beyond the BFL shadow is due to reflection by the flat Ge crystal outside of the BFL area.

The sample was mounted on a three-axes XYZ remote controlled sample stage built from 3 Microcontrole translators with a $0.1\ \mu\text{m}$ steps length, located on the focal distance of 10 cm from the BFL. A Caleo video color optical microscope (magnification 700) was used to locate the sample in

FIG. 3. X-ray image of the focused beam.

FIG. 4. The distribution of the transmission intensity mapped by scanning the $4\ \mu\text{m}$ W-wire cross through the x-ray (7.6 keV) beam.

the beam and to identify the region of interest on the sample. Adjustment of the sample to the x-ray focal spot was done as follows. First, the W-wire $4\ \mu\text{m}$ cross placed instead of the sample, was adjusted to the focused x-ray beam, using the drastic decreasing in the intensity of the x-ray beam measured by PIN photodiode. A $4\ \mu\text{m}$ W-wire cross was scanned through the beam, the transmission intensity profile is presented in the Fig. 4. Second, the hairs cross in the microscope are set to the W-wire cross. Finally, the sample (Cr mask) replaces the W-wire cross and the analysis point on it is set to the hairs cross. The analysis point can be set to the x-ray focal spot within a few microns.

A Cr mask MRS-2 (magnification reference standard) from Geller Microanalytical Laboratory with a chromium layer of 80 nm thickness was used as a test object in order to measure the resolution and the sensitivity of the microprobe.

The fluorescence signal was recorded with a Princeton Gamma Teek Si(Li) detector of $13\ \text{mm}^2$ area and 148 eV energy resolution for 5.9 keV photons. A collimator was set in the axis of the detector to ensure that only those photons arising from the sample can enter its active area. To suppress further background due to scattering the detector was mounted in the plane of the synchrotron ring and at 90° to the incident beam. Due to the high horizontal polarization of the synchrotron light these geometrical conditions reduce the Rayleigh and the Compton scattering from the sample to a minimum. Lead shielding was also used around the detector to decrease the background due to scattering of the incoming beam through its air path to the sample.

Pulses from the detector were processed through a Tenelec TC 144 amplifier operating in the triangular shaping mode. The pile up rejection output was sent to a pulse high analyzer that is a Nucleus PCA card installed in an IBM PC-AT3 computer.

In order to synchronize and to control the sample move-

FIG. 5. Experimental variation of Cr K_{α} fluorescence signal upon scanning a Cr-strip pattern.

ments and data collection a PC-based software package called PILOT, developed by LURE, was used. To reduce the amount of data from a scan the software saves the regions of interest (ROI) for each point, instead of saving the full spectrum, for up to 10 ROIs. This also reduces the time of data treatment in sacrifice of the precision in peak analysis, e.g., tails of neighboring large peaks can introduce systematic errors in small peak areas.

Figure 5 shows the sum of a scan across one of the Cr strips. The step width was about $0.1 \mu\text{m}$. The counting time per point was 30 s. The background of about 70 c/s is due to secondary generated fluorescence of neighboring Cr strips. The 25% and 75% markers indicate the effective x-ray imaging probe dimension. The knife-edge scan data shows a focal spot of $0.7 \mu\text{m}$. The intensity in the focal spot was measured to 10^8 ph/s.

The developed submicrometer fluorescence microprobe was applied for elemental analysis of small (10 to $40 \mu\text{m}$) inclusions in micrometeorites collected in Antarctica, by melting and filtering large amounts of the blue ice. These micrometeorites are mainly composed of disequibrated assemblages of pyroxene and olivine phases (iron and magnesium silicates). In about 60% of these specimens a new phase mainly composed of carbon, oxygen, phosphorus, and sulfur has been discovered. Due to its major elemental composi-

tion, this new phase has been called COPS. The formation of this phase is not yet understood and trace element analysis could help to determine the origin of its material.

One of the meteorite was embedded in epoxy and polished until a COPS inclusion appeared in view. The micrometeorite was studied at 13.5 keV using a submicrometer sized beam from a BFL.

A line scan through the COPS inclusion was performed with $1 \mu\text{m}$ steps. Each spectrum was collected for 10 s and ROI corresponding to Ca, Ti, Cr, Fe, Ni, Ge, and scattered peak (13.5 keV) were recorded. Results are shown in Fig. 6 where the count rate in each ROI is plotted versus the position on the sample. As can be seen in Fig. 6 Fe has an increase in concentration going from the edge to the other edge, whereas the other elements are constant.

The data shown in Fig. 6 are significant for the various elements, because the background due to scattering was very low in this energy region. Further if some of the data were due to the low energy tail of, e.g., the strong Fe peak this contribution should follow the same variation as the iron peak which is not the case.

III. CONCLUSION

Two-dimensional sub- μm fluorescence microprobe has been demonstrated for the first time for the combination of a Bragg-Fresnel lens and a high brilliance undulator at a third generation SR source. The fluorescence knife-edge measurement shows with high accuracy the spatial resolution of the circular Bragg-Fresnel lens that is about $0.7 \mu\text{m}$. A flux of 10^8 photons per s in a focal spot was achieved in very narrow bandpath 10^{-5} . In the case when a resolution of one or a few microns is sufficient and a higher flux is needed the elliptical multilayer BFL can be applied.⁷

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FIG. 6. Experimental fluorescence spectrum of COPS inclusion vs the position on the sample.

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